



PATENT

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July 20, 2006  
Date

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Appl. No. : 10/699,256

Confirmation No. : 9603

Applicants : Chih-Chen Cho and Zhongze Wang

Filed : October 30, 2003

Attorney Docket No.: 500982.02 (30016/US/2)

Art Unit : 2822

Customer No. : 27,076

Examiner : Toniae M. Thomas

Title : METHODS FOR MAKING SEMICONDUCTOR STRUCTURES HAVING  
HIGH-SPEED AREAS AND HIGH-DENSITY AREAS

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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

RESPONSE UNDER 37 C.F.R. § 1.111

Sir:

Please amend the above-captioned patent application as follows:

A Listing of Claims reflecting the currently pending claims begins on page 2 of this paper.

Remarks begin on page 8 of this paper.